Serial No. 10/084,925

Conj.

a gate electrode provided on said gate insulating film and formed with a P-N junction including a

- P-type semiconductor region and an N-type semiconductor region,
- 8 wherein said P-type senficonductor region and said N-type semiconductor region of said P-N
- junction of said gate electronic are electrically insulated,

β3

11

wherein said gate electrode includes a first gate portion provided above said channel region and

- a second gate portion provided above a region which is not said channel region, and said second gate
- portion includes said P-N junction.

03

6. (Amended) The semiconductor device according to claim 1, further comprising;

a body region formed of a semiconductor under said channel region;

a buried insulating film provided under said body region, said source region, and said drain region;

and

a semiconductor substrate region provided under said buried insulating film.